

<b>Notice of References Cited</b>	Application/Control No. 10/811,844	Applicant(s)/Patent Under Reexamination TANIKAWA ET AL.	
	Examiner Noah Kamen	Art Unit 3747	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2002/0088423 A1	07-2002	Minegishi et al.	123/184.55
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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